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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Masahiro NAKAYAMA, et al.

**RESPONSE UNDER 37 C.F.R. 1.116  
EXPEDITED PROCEDURE**

Application No.: 10/662,524

Customer No.: 20277

Filed: September 16, 2003

Confirmation No.: 1716

Group Art Unit: 3723

Examiner: Dung V. Nguyen

Title: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND  
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

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11-17-2006

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
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Sir:

The following Amendment and Remarks are submitted in response to the final Office

Action dated August 8, 2006, pursuant to 37 C.F.R. § 1.116.

**Amendments to the Claims begin on page 2.**

**Remarks begin on page 4.**